



Quantum wells for photonics

New techniques for growing semiconductors with alternating ultrathin layers allow one to produce materials with made-to-order electro-optic properties and potential uses such as optical modulators and solid-state photomultipliers.

Daniel S. Chemla

The crystalline and electronic structures of semiconductors reflect a delicate balance of very large electromagnetic forces, and consequently minute compositional variations or small perturbations can induce large changes in the properties of these materials. For several decades now, research scientists and device designers have exploited this exceptional flexibility to tailor the electronic and optical properties of semiconductors for a variety of fundamental studies and applications. Semiconductor technology has made its most apparent impact, of course, in solid-state electronics.

In recent years, however, the field of photonics, which combines laser physics, electro-optics and nonlinear optics, has burgeoned. Modern lightwave communications exemplify photonic systems: Here optical signals are generated, modulated, transmitted and detected before they are transformed to electrical form for final use. Information processing is another example. Optical processing of information has several advantages over electronic processing, which must usually be done serially and is limited in speed by the broadening of pulses in interconnecting wires and is limited in density by "cross talk" between those wires. Optical systems capable of handling very large quantities of data await only the development of convenient digital optical logic elements with low switching energy.

Daniel Chemla is head of the quantum physics and electronics research department at AT&T Bell Laboratories, in Holmdel, New Jersey.

An ideal material for electro-optic applications such as those mentioned above would be able to transform light into current and vice versa for detection and emission. The material would also exhibit large electronic and optical nonlinearities that would allow one to use it as a transistor and optical gate. By taking advantage of both of these nonlinearities at the same time, one can use the material as an optical modulator. In the last decade we have seen the development of new methods for growing materials epitaxially. Techniques such as molecular beam expitaxy1 and metal-organic chemical vapor deposition2 combine an ultraclean growth environment and a slow growth rate to produce samples of extremely high quality. In particular, these techniques allow one to produce heterojunctions that are atomically abrupt and planar. With growth rates as low as 1 Å/sec, one can make layered structures with layer thicknesses ranging from a few angstroms to a few microns, as well as microstructures with continuously tuned composition profiles. These artificial media exhibit novel properties not shown by the parent compounds in the bulk.

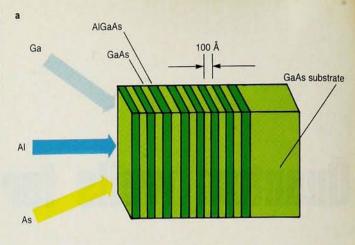
Structures consisting of stacks of ultrathin layers are called superlattices or quantum-well structures,³ and those with continuously varying compositions are called graded-gap structures. In this article I discuss the basic opto-electronic properties of quantum-well and graded-gap structures and describe some recent research that has potential applications in photonics.^{4,5} I begin with a look at the physics of the

layered structures, which feature bandgap discontinuities, or abrupt spatial changes in the energy gap between the valence band and the conduction band. Explaining the opto-electronic properties of these quantum-well structures will bring me to such topics as roomtemperature excitons, optical nonlinearities and the behavior of carriers constrained to move in two dimensions only (figure 1). I will also say a few words about the structures whose compositions-and band-gap energiesvary smoothly. These graded-gap materials exhibit unusual energy-band gradients that imitate electric fields. which device designers can use to adjust the drift velocities of carriers over a large range. Finally, I will consider the wide variety of present and potential applications that discontinuous and graded-gap materials have in photonics. These applications range from mode-locking laser diodes and high-speed optical samplers to solidstate photomultipliers and optical gates with ultralow switching energies.

The materials. The compound III-V semiconductors, which are made from group-III and group-V elements, have the basic properties necessary for fabricating quantum-well and graded-gap materials. These semiconductors have a direct band gap, that is, they can emit or absorb light without the help of lattice vibrations, and thus they are very efficient absorbers and emitters. They also have large carrier mobilities and are easily doped. More importantly, they can form various solid solutions with identical crystal structures and well-matched lattice parameters but

Quantum-well structure and corresponding real-space energy band structure. The schematic diagram in a shows compositional profiling in thin layers. The circle in b represents an exciton in the bulk compound, and the ellipse represents an exciton confined in a layer with a low band gap.

Figure 2



Energy levels

High-energy band gap

Low-energy band gap

Valence band

Layer thicknesses

with different energy gaps and refrac-

The chemical and physical compatibilities of solid solutions of various III-V compounds make it possible to grow heterostructures involving several compounds. One can make heterostructures with high-quality interfaces, and tailor the optical and electronic discontinuities for specific applications. Although structures have not yet been optimized for more than one function at a time, the III-V alloys could in principle be used for several functions at once. This possibility has motivated much of the tremendous effort over the last 20 years to synthesize III-V semiconductors, study and understand their fundamental characteristics and manipulate their properties. (See Venkatesh Narayanamurti's article on crystalline semiconductor heterostructures, PHYSICS TODAY, October, page 24.)

Physics and structure

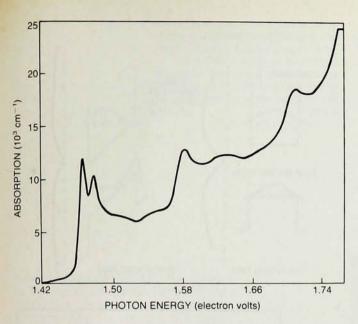
Electrons and holes can propagate freely in the periodic potential of semiconductors. The major changes in the dynamics of these charged carriers caused by the semiconductor environment are: replacement of the freeelectron masses by much smaller electron and hole effective masses, and a substantial increase in the dielectric constant. As a consequence of these changes, basic physical quantities such as the Bohr radius and the Rydberg constant are drastically modified in semiconductors. In the case of the III-V compounds, the Bohr radius ranges from 10 Å to 500 Å, corresponding to effective Rydberg constants ranging from 100 meV to 1 meV.

The change of scale in these natural units causes a number of processes involving electrons and holes in semiconductors to be different from the free-space atomic processes that they parallel. Thus carriers in semiconductors are more sensitive to small perturbations, a situation that one can exploit for device applications and that one can use to obtain model systems not encountered with free particles. In superlattices and graded-gap structures, modifications of free-particle behavior due to quantum size effects are important. Quantum size effects arise when the dimensions of a quantum system become comparable to the Bohr radius; one can observe these effects in semiconductor microstructures that have dimensions on the order of 100 Å.

The simplest examples of systems where size produces fundamental modifications of optical and electronic properties are quantum-well structures.⁶ These structures consist of ultrathin layers of two or more compounds grown one on another periodically, as figure 2a indicates. Because the layers have

different band gaps, the energy bands present discontinuities in real space, as shown schematically in figure 2b. Quantization of the carrier motion in the direction perpendicular to the layers produces a set of discrete energy levels. If the energy discontinuities are large enough and the layers with large band gaps are wide enough, then there will be little interaction between adiacent low-gap layers. The carriers confined in each of those layers will behave almost independently. Hence the name quantum-well structures. When the barriers are narrow, or when the energy of a state is comparable to the energy discontinuities, the interaction between layers is important. The wavefunctions of the carriers are extended perpendicularly to the layers, so the behavior of the carriers is modified by the periodic long-range modulation superimposed upon the crystalline potential. Hence the name superlattices.

In quantum-well structures, electrons and holes do not move with their usual three degrees of freedom. They show one-dimensional behavior normal to the layers and two-dimensional be-



Absorption spectrum of a GaAs-Al_{0.3} Ga_{0.7} As quantum-well structure. The steps in this room-temperature spectrum mark transistions between sub-bands. The peaks at the edges of the steps are due to excitons. Figure 3

havior in the planes of the layers. This reduced dimensionality induces drastic changes in the electric and optical properties of quantum-well materials. For example, one can introduce impurities in the large-gap layers in such a way that the impurity nuclei will be trapped while the carriers that are introduced can migrate toward the lowgap layers and form two-dimensional gases at the interfaces. This technique, known as modulation doping,7 produces a physical separation between impurities and carriers, leaving the carriers highly mobile. Solid-state physicists have taken advantage of the properties of two-dimensional electron gases in the fabrication of high-speed field-effect transistors and in fundamental studies on the integral and fractional quantum Hall effects.8

In layered structures, the conduction and valence bands become sets of two-dimensional sub-bands with step-like densities of states. This increases the number of states that contribute to the optical transitions at the absorption edge. Hence the absorption spectra of quantum-well structures are significantly different from those of three-dimensional semiconductors. Device designers have used this effect to obtain very-low-threshold diode lasers by including quantum wells in the active region of the diode.⁹

Excitons. For undoped quantum-well structures, excitonic effects are further modified by the confinement of carriers. As we will see later, optical effects associated with excitons play a crucial role in many opto-electronics applications of quantum-well structures. When a high-purity semiconductor ab-

sorbs a photon, the electron that is promoted to the conduction band interacts with the hole left in the valence band. The electron and hole can form a bound-state analog of the hydrogen atom called an exciton. This final-state interaction produces a set of discrete and very strong absorption lines just under the band gap. Because the binding energy of the exciton-the energy of its 1s state, or its effective Rydberg constant—is very small, excitons are very fragile. Excitons are sensitive to any kind of defect and are usually observed only at low temperature because they are easily broken apart by thermal phonons.

In a quantum-well structure with layer thicknesses smaller than the Bohr radius, the exciton has to modify its structure to fit into the low-gap layers. It flattens and shrinks. This is illustrated in figure 2b by the colored circle, which represents the 280-Å-diameter exciton of bulk GaAs, and by the ellipse, which represents the exciton when it is confined in a 100-Å quantum well. The electron and the hole are forced to orbit closer to each other, and the binding energy increases by a factor of two to three.

This added stability makes the exciton's resonances observable at room temperature, as demonstrated clearly by the absorption spectrum shown in figure 3. This spectrum was measured at room temperature in a high-quality quantum-well structure that Arthur Gossard grew at AT&T Bell Laboratories. The sample has 65 periods of 96-Å-thick layers of GaAs alternating with 98-Å-thick layers of Al_{0.3} Ga_{0.7} As. In figure 3 one can see the steps

associated with the transitions between sub-bands, and one can see exciton peaks before each step. Exciton peaks as clearly resolved as this are usually seen only at very low temperature in bulk semiconductors of ultrahigh purity. The peaks are so apparent in quantum-well structures not only because of the increased exciton binding energy but also because the confinement strongly enhances the contrast with the continuum.10 In bulk GaAs there is only one exciton resonance. The reduced symmetry of quantumwell structures, however, produces two valence bands and hence two excitons. This results in the double peak seen at the onset of the first transition. Similar exciton resonances, well resolved at high temperature, have been seen in the quantum-well material GaInAs-AlInAs, whose band gap is in the infrared.

It was at first thought that the room-temperature excitonic resonances in quantum-well structures simply offered a convenient way of making use of the large, intensity-dependent absorption and refraction effects usually seen at low temperatures in bulk semi-conductors. Indeed quantum-well structures do have giant optical nonlinearities, but these originate from the novel physical properties of the layered structures and present a richer array of potential applications than do the nonlinearities observed at low temperatures in bulk crystals.

When light tuned to the exciton peak illuminates a quantum-well structure, bound electron-hole pairs are first generated and then quickly ionized by the large population of thermal phon-

Excitonic wavefunctions without and with an applied electric field (a), and the quantum confined Stark shift in an absorption spectrum (b). The wavefunctions illustrate how the walls of a quantum well hold an electron and hole in a bound state, even at applied fields much stronger than the classical ionization field. The absorption spectra are those of a quantum-well structure under three different static electric fields applied normal to the layers. The fields are 104 V/cm (bottom curve), 5×10^4 V/cm (middle curve) and 7.5×10^4 V/cm (top curve).

Electron wavefunction Well wall Exciton wavefunction in the plane of a layer Hole wavefunction With electric field Without electric field

room temperature the average thermal b energy kT is about three times larger than the exciton binding energy. Note for comparison that the ionization temperature for hydrogen atoms is about ABSORPTION COEFFICIENT (cm 10 000 2×105 K. Recent measurements with femtosecond optical spectroscopic techniques11 found the ionization time of excitons in quantum-well structures to be 300 fsec. Due to the effects of the electron-hole plasma, the coefficient of absorption and the index of refraction depend strongly on the intensity of the 5000 incident light. These dependencies show up in measurements with continuous-wave laser light as well as with picosecond laser pulses. These nonlinearities are several orders of magnitude larger than those observed in normal semiconductors, yet they are 1.43 1.48 still about half as large as the nonlinearities produced by the selective gen-PHOTON ENERGY (electron volts)

It is commonly believed that the charged electron-hole plasma is more efficient than the neutral bound pairs in shielding electrostatic forces. This is true if the electrons and holes are at the same temperature. However, excitation with ultrashort optical pulses at the resonant frequency generates an exciton gas of temperature near 0 K that relaxes toward a warm electronhole plasma of temperature around 300 K by absorbing phonons. This most unusual reversed relaxation, and the reduced strength of screening due to the reduced dimensionality in the quantum-well structure, together prolavers. duce very large optical nonlinearities that have two stages—a stage lasting for subpicosecond times, corresponding to the time it takes for the exciton to ionize, and a stage lasting for nanose-

recombine.10 Excitons in quantum-well materials are also sensitive to electrostatic perturbations. Because the carrier wavefunctions extend to about 100 Å, and

conds, corresponding to the time it

takes for the electron-hole pair to

ons present at room temperature. At

eration of excitons with femtosecond

laser sources.1

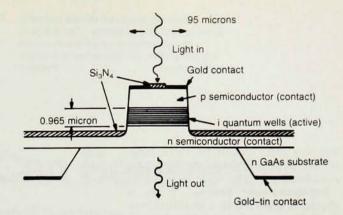
because the confinement or binding energies are only 10-100 meV, moderate electric fields of order 10 mV per 100 Å, or 104 V/cm, cause significant perturbations. When an electrostatic field is applied to a three-dimensional exciton, it induces a Stark effect analogous to that seen on atoms: There is a small shift in energy levels that is quickly masked because the energy levels are broadened by the exciton's ionization under the influence of the electric field. One sees this in quantum-well systems when the field is applied parallel to the planes of the

With a perpendicular field, however, an absolutely new process occurs.13 The field pushes the electron and the hole apart, but the wall of the well prevents ionization by constraining the particles to stay close enough to remain bound, as figure 4a indicates. The ionization can only occur when the particles tunnel out of the well. Consequently, it is possible to apply fields as large as 50 times the classical ionization field, inducing redshifts (figure 4b)

in the absorption peak 2.5 times the binding energy, and still observe exciton resonances! This phenomenon, which figure 1 illustrates, is called the quantum confined Stark effect. course, one cannot create a similar situation for atoms, but quantum-well structures provide model systems in which one can study the effects of such extreme conditions and make tests against theory. The observed shifts due to the quantum confined Stark effect are well accounted for by the field-induced variations in the energy of the single-particle state and by pair attraction. 13 This effect also allows one to shift an abrupt and highly absorbing edge into a spectral region where the sample is normally transparent. Such shifts have obvious applications in optical modulation and optical logic, and I will discuss these below.

As figure 2b indicates, the conduction band and the valence band do not contribute equally to the total bandgap discontinuity at a heterojunction. Recent measurements14 on a GaAs-AlGaAs quantum-well structure, for

High-speed optical modulator and its optical response to an electrical pulse. The schematic diagram shows a p-i-n diode with a quantum-well optical modulator. The speed of the device is limited by the circuit's RC constant and by the large diameter of the quantum-well structure.



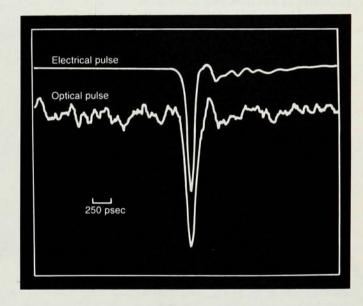
example, indicate that $\Delta E_{\rm c}$, the change in the energy level of the bottom of the conduction band as one crosses a heterojunction, is about -1.5 times $\Delta E_{\rm v}$, the change in the energy level of the top of the valence band across the junction. This intrinsic asymmetry between electrons and holes can produce spectacular effects such as impact ionization, which depends critically on energy gains at heterojunctions. As we will see, new types of photodetectors take advantage of this asymmetry.

Graded gaps. So far we have discussed only discontinuous heterojunctions. There is, however, a more subtle way to engineer band structure: by playing with the composition profile. A continuous spatial variation of the composition induces a gradient of the energy bands equivalent to an internal electric field, and because the valence and conduction bands experience different discontinuities, the effective fields seen by holes and electrons are not the same.5 One can use this new degree of freedom to produce complex internal field profiles, and thus to act locally on the carrier drift velocity. For example, experimenters have measured15 an equivalent field of order of 104 V/cm in a linearly graded gap structure made from Al, Ga1-x As. Such a field can accelerate electrons to velocities as high as 2×107 cm/

Microstructures for photonics

The special properties of quantumwell materials suit them to a variety of applications in photonics. Below I consider some of these properties and applications.

The optical nonlinearities of quantum-well structures close to the band edge are the largest measured so far in any semiconductor at room temperature. Because quantum-well structures are easily tuned to laser-diode wavelengths, they have been used in applications where one wants a small amount of excitation to produce a large change in absorption or refraction.



Short-pulse light sources. Passive mode locking of laser diodes allows for compact and efficient short-pulse light sources. However, the design of such mode-locking diodes has suffered from a shortage of adequate saturable absorbers with large enough cross section and short recovery time. Recent experiments on quantum-well structures implanted with light ions have shortened to 150 psec the recombination time of carriers generated by the ionization of excitons. Solid-state physicists have used these fast-recovery saturable absorbers to make stable and reliable mode-locking laser diodes. Such diodes, made from GaAs, have emitted16 pulses as short as 1.6 psec, the shortest regular pulse trains yet delivered by a diode laser.

Optical switches in cavities. Experiments have demonstrated ¹⁷ optical bistability in a sample of quantum-well material held in a Fabry-Perot resonator. Theory indicates ¹⁸ that optical switches made from quantum-well materials in precisely tuned etalons will have very low switching energies

High-speed optical modulators. Recent experiments have used the quantum confined Stark effect to achieve the high-speed modulation of light from laser diodes. To build such a modulator, one grows a quantum-well structure in the intrinsic region of a p-i-n diode, as figure 5 shows. By putting a reverse bias on the resulting device, one applies a field without causing current to flow. When the modulator represented in figure 5 was given a 122psec electrical pulse, it subjected the laser light passing through it to a 131psec 2.3-dB attenuation. The modulator's response was limited by the effects of capacitance in its 95-micron-diameter structure.19 The speed of the quantum confined Stark effect is limited only by how quickly the exciton envelope function can follow the applied field. At present, however, the limit is how fast one can change the applied field, so faster operation should be feasible with devices having smaller areas and therefore smaller capacitances. The quantum-well structure that imposed the 2.3-dB modulation

Self-electro-optic device and plots showing its optical bistability. The device in the schematic diagram shows optical bistability when it is connected to a simple resistive load. Figure 6 V_o

I

Quantum-well structure

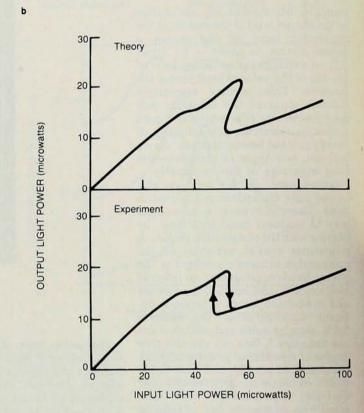
was only about one micron thick; longer light paths increase the attenuation considerably.

Self-electro-optic devices. When a photon is absorbed in a quantum confined Stark effect p-i-n structure, it generates an electron-hole pair that is separated by the field; here the modulator behaves like a photodetector of unit quantum efficiency. The ability of such a p-i-n device to act as both a modulator and a photodetector provides an internal feedback mechanism when the device is connected to an electronic circuit. This is the basis of a new category of devices, known as selfelectro-optic devices, that can operate as optical gates with very low switching energy, self-linearized modulators and optical level shifters.20

The optical gate represented in figure 6a operates as follows: One applies just enough voltage to the device to shift the absorption edge so that there is little absorption at the exciton peak; then one directs a light beam of varying intensity onto the device. As the beam's intensity increases, it generates a photocurrent that induces a voltage drop across the resistor. The voltage across the device decreases, the edge shifts back and the absorption increases, increasing the photocurrent. This cycle continues until the device switches to a state of low transmission. The switch back to a highly transmitting state does not occur at the same incident intensity because the selfelectro-optic device is now absorbing. Therefore the gate response, shown in figure 6b, is an optical hysteresis loop.

The self-electro-optic devices demonstrated to date typically have total switching energies of 20 fJ per square micron. This switching energy is only one-sixth that reported for any other optically bistable device, despite the fact that self-electro-optic devices operate without resonant cavities. The total switching energy comprises two parts: resonant optical energy, which accounts for about 20% of the total, and electrical energy, which accounts for the other 80%. Self-electro-optic devices are compatible with other III-V semiconductor technologies, and should fit into large-scale integrated arrays.

High-gain avalanche photodetectors can be built from a solid with a large difference between the rates at which electrons and holes create electron—

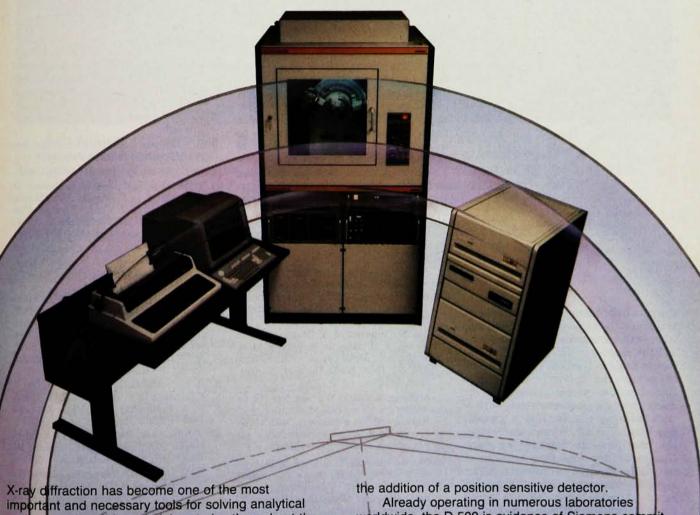


hole pairs throughout impact ionization. In gallium arsenide, unfortunately, the two ionization rates are about the same. Furthermore, avalanche multiplication is intrinsically a noisy process because of the randomness of the ionization events, and that causes statistical fluctuations in the gain. New concepts based on quantum-well and graded-gap structures have overcome these obstacles. Figure 7a shows the band structure of a p-i-n diode that contains a quantum-well structure in its intrinsic region. When a hot electron enters a gallium arsenide quantum well, it suddenly gains an energy $\Delta E_{\rm c}$. The ionization threshold for electrons is thus reduced from $\Delta E_{
m th}$ to $\Delta E_{\rm th} - \Delta E_{\rm c}$, whereas for the holes it is reduced to $\Delta E_{\rm th} - \Delta E_{\rm v}$. Because the ionization rates depend exponentially on the thresholds, one can greatly enhance the ratio of electron and hole ionization rates. AlGaAs-GaAs avalanche photodetectors have shown²¹ ratios as large as seven. The performances can be improved further by using a sawtooth profile with regions of linear grading followed by abrupt steps, as shown in figure 7b. When one applies a static field to the structure, figure 7c, the impact ionization events occur at each step deterministically, and preferentially for the electrons. The resulting multiplication processes are no longer random, and the gain is almost noise free. The graded-gap structure acts as a solid-state photomultiplier, with the steps in the energy bands corresponding to the dynodes of a traditional photomultiplier tube.21

Fast transistors. The transit time of

The Choice You Can Believe In

The D 500 X-ray Diffraction System



X-ray offraction has become one of the most important and necessary tools for solving analytical and research problems in laboratories throughout the world, and the Siemens D 500 diffractometer provides the universal capabilities for satisfying the widest

range of applications.

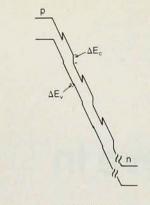
the D 500 is the one system that combines a wide selection of accessories with a comprehensive but user-oriented software package that enables you to perform routine powder diffraction analysis in production, control or sophisticated research by the addition of options, such as stress, texture, high-temperature, and Theta-Theta diffractometry — or dramatically speed up the analysis with

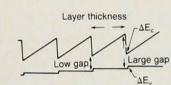
Already operating in numerous laboratories worldwide, the D 500 is evidence of Siemens commitment to satisfying all your present and future needs in x-ray diffraction. Siemens is the choice that you can believe in for x-ray diffraction systems. For more information write or call: Siemens AG, Analytical Systems E 689, D 7500 Karlsruhe 21, P.O. Box 21 1262, Federal Republic of Germany, Tel: (0721) 595-2425, Telex: 7826851.

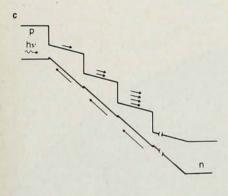
Siemens-Allis, Inc., Analytical Systems, One Computer Drive, P.O. Box 5477, Cherry Hill, NJ 08034, (609) 424-9210.

Siemens...The company you can believe in.

Circle number 31 on Reader Service Card







the minority carriers in the base of a transistor is governed by diffusion. Almost three decades ago, H. Kroemer of RCA proposed22 introducing quasielectric fields in the base of a transistor to reduce the carrier transit time. Experimenters recently succeeded in doing this in a phototransistor with a wide-band-gap emitter and a gradedgap base. The 104 V/cm quasifield in the base gave an intrinsic response time of 20 psec-less than one-fifth of the diffusion time of carriers in an identical structure without a graded base.21 Further improvements under study include the ballistic launching of electrons into the base by a conductionband discontinuity at the emitter-base heterojunction.

The examples I have given of semiconductor properties that are strongly modified by quantum size effects and compositional profiling are just a limited set chosen for their relevance to photonics. In principle, we can use abrupt heterojunctions, selective doping and continuous composition grading to engineer, in almost any arbitrary fashion, the energy-band structure of semiconductor microstructures. The recently developed epitaxial growth Band structures. a: Band structure of an avalanche photodetector made from a p-i-n quantum-well structure. b: Band structure of a sawtooth graded-gap multilayer structure. The composition varies linearly from the low-gap compound to the large-gap compound and then abruptly switches back to the low-gap composition. c: Band structure of a graded-gap solid-state photomultiplier with an applied bias voltage. The arrows illustrate how the electrons multiply by impact ionization at discontinuities in the conduction band whereas the holes do not gain enough energy at valence-band discontinuities to participate in impact ionization.

techniques already allow us to control the compositions of samples along one dimension. We can envision new techniques that in the near future will give us atomic-scale control over growth in three dimensions. This will enable us to tailor the local band structure of samples according to specific designs. There is no doubt that the resulting materials will present new properties—some unsuspected—and that these new properties will give rise to new applications.

References

- See, for example, L. L. Chang, K. Ploog, eds., Molecular Beam Epitaxy and Heterostructures, NATO Advanced Science Institute Series, Nijhoff, Dordrecht (1985).
- See, for example, J. B. Mullin, S. J. C. Irvine, R. H. Moss, P. N. Robson, D. R. Wight, eds., Metal Organic Vapor Phase Epitaxy 1984, North-Holland, Amsterdam (1984).
- L. Esaki, R. Tsu, IBM J. Res. Dev. 14, 61 (1970); for an outline of the history of Esaki's and Tsu's discovery, with Leroy Chang, of artificial semiconductor superlattices, PHYSICS TODAY, March, p. 87.
- See, for example, D. S. Chemla, D. A. B. Miller, P. W. Smith, Device and Circuit Applications of III-V Semiconductor Superlattices and Modulation Doping, R. Dingle, ed., Academic, New York (1985).
- See, for example, F. Capasso, Device and Circuit Applications of III-V Semiconductor Superlattices and Modulation Doping, R. Dingle, ed., Academic, New York (1985).
- R. Dingle, Festkörperprobleme 15, H. J. Queisser, ed., Pergamon, Braunschweig (1975).
- R. Dingle, H. L. Stormer, A. C. Gossard, W. Wiegmann, Appl. Phys. Lett. 33, 665 (1978); H. L. Stormer, Surf. Sci. 132, 519 (1983).
- T. Mimura, S. Hiyamizu, T. Fujii, K. Nambu, Japan J. App. Phys. 19, L225 (1980);
 D. Delagebeaubeuf, P. Delesclilse, P. Etienne, M. Laviron, J. Cha-

- plart, N. T. Linh, Electron Lett. 16, 667 (1980); H. L. Stormer, Festkörperprobleme 24, P. Grosse, ed., Vieweg, Braunschweig (1984).
- See Y. Suematsu's article on page 32 of this issue.
- D. S. Chemla, D. A. B. Miller, J. Opt. Soc. Am. B, to be published July 1985.
- 11. C. V. Shank, Science 219, 1031 (1983).
- W. H. Knox, R. F. Fork, M. C. Downer, D. A. B. Miller, D. S. Chemla, C. V. Shank, Proc. Fourth Int. Conf. Ultrafast Phenomena, Springer-Verlag, Berlin (1984), p. 162; Phys. Rev. Lett. 54, 1306 (1985).
- D. A. B. Miller, D. S. Chemla, T. C. Damen, A. C. Gossard, W. Wiegman, T. H. Wood, C. A. Burrus, Phys. Rev. Lett. 53, 2173 (1984).
- R. C. Miller, A. C. Gossard, D. A. Kleinman, O. Munteanu, Phys. Rev. B29, 3740 (1984); for a review of exciton spectroscopy in quantum-well structures, see R. C. Miller, D. A. Kleinman, Proc. 3rd Trieste IUPAP Semiconductor Symp., J. Lumin. 30, 520 (1985).
- B. F. Levine, C. G. Bethea, W. T. Tsand, F. Capasso, K. K. Thornber, R. C. Fluton, D. A. Kleinman, Appl. Phys. Lett. 43, 769 (1983).
- Y. Silberberg, P. W. Smith, D. J. Eilenberger, D. A. B. Miller, A. C. Gossard, W. Wiegmann, Optics Lett. 9, 507 (1984).
- H. M. Gibbs, S. S. Tarng, J. L. Jewell, D. A. Weinberger, K. Tai, A. C. Gossard, S. L. McCall, A. Pasner, W. Wiegmann, Appl. Phys. Lett. 41, 221 (1982).
- P. W. Smith, Proc. Conf. Electro '83, session record 11/1, IEEE, New York (1983).
- T. H. Wood, C. A. Burrus, D. A. B. Miller, D. S. Chemla, T. C. Damen, A. C. Gossard, W. Wiegmann, IEEE J. Quantum Electron. QE-21, 117 (1985).
- D. A. B. Miller, D. S. Chemla, T. C. Damen, A. C. Gossard, W. Wiegman, T. H. Wood, C. A. Burrus, Appl. Phys. Lett. 45, 13 (1984); Optics Lett. 9, 567 (1984); to be published in IEEE J. Quantum Electron. (1985).
- 21. F. Capasso, Sur. Sci. 513, 142 (1984).
- 22. H. Kroemer, RCA Rev. 18, 332 (1957).